

35.C11969 REI.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Reissue Application of: : Previous  
NOBUMASA SUZUKI : ) Examiner: L. Alejandro  
Patent No.: 5,803,975 : ) Previous  
Filed: Herewith : ) Group Art Unit: 1763  
For: MICROWAVE PLASMA : )  
PROCESSING APPARATUS AND : )  
METHOD THEREFOR : )  
Issued: September 8, 1998 : )  
September 7, 2000

**BOX REISSUE**

Commissioner for Patents  
Washington, D.C. 20231

PRELIMINARY AMENDMENT

The present application is for reissue of the above-identified issued U.S. Patent No. 5,803,975. The errors which create the basis for this reissue application relate to the failure to claim the invention as broadly as the inventor was entitled to in view of his disclosure. Additionally, the Applicant in some instances failed to claim the invention as specifically as believed necessary to adequately describe the scope of his invention. Accordingly, Applicant seeks to add new claims to obtain claims of appropriate scope and asks that the application be amended as follows: